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Cech, Jiri; Taboryski, Rafael J.

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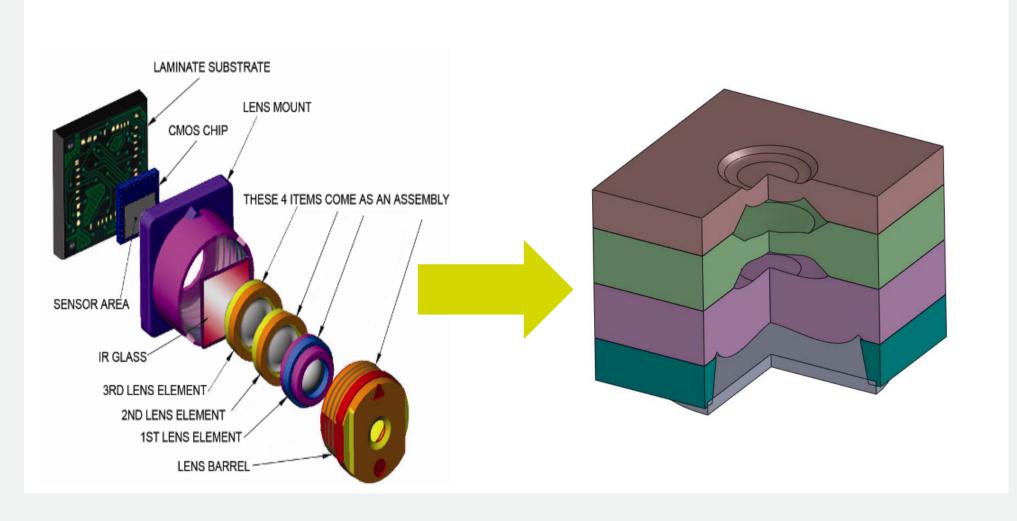
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# DTU Nanotech Department of Micro- and Nanotechnology

# **Developing fabrication methods for** nanostructured wafer-based precise polymer elements

# Jirka Cech and Rafael Taboryski



Conventional camera module consisting of multiple discrete components as opposed to wafer level assembly based modules, where one prepares 3000 - 4000 dies with complete modules at once on 4" wafer.

# Motivation

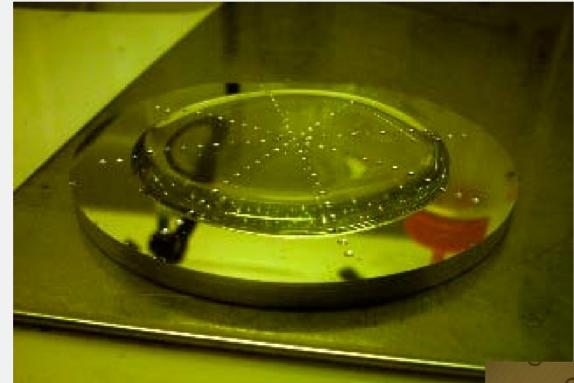
Use well established semiconductor fabrication principles of integration, parallelization, wafer level manufacturing. This allows to make more precise, advanced optical design (aspheric) using automated processing. Cost for single wafer level camera module (3 lens stack, 3 spacers and 3 MPix sensor) was calculated to be \$1.26 with 80% yield.

# Approach

- Make wafer sized master for lens surfaces
- Replicate lenses
- Prepare wafers with apertures, filters, spacers,
- Wafers with CMOS sensors • Readout circutry
- Stack, Align,
- Bond, Cure it
- Dice
- Mount to baseboard
- Test

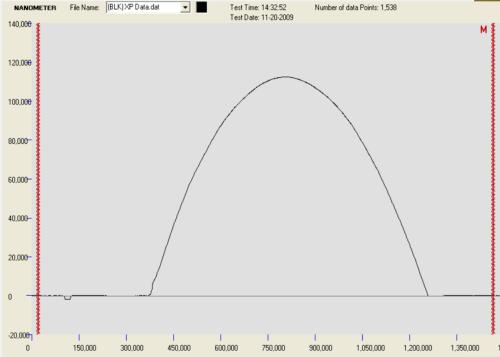


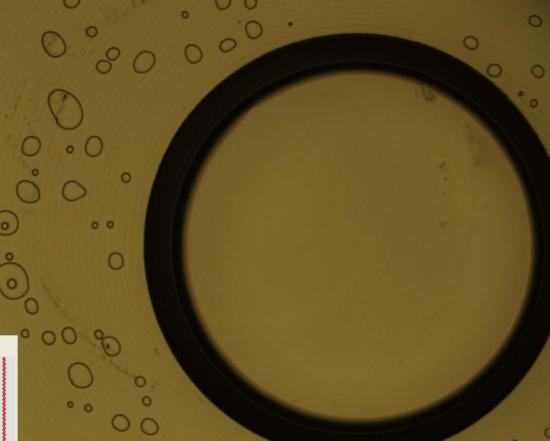
# **Initial Results with Ormocer**



Aluminum tool with microlenses Special anti-adhesion coating Spreading via spin coating Ex-situ UV curing Post-exposure bake

Optical microscopy image Polymer outside lenses Bubbles outside lenses Nonconforming shape



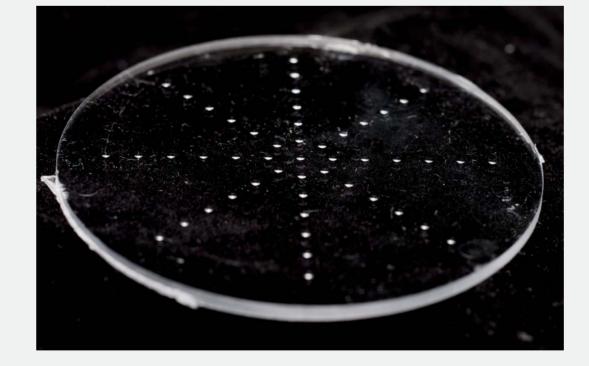


Mechanical profilometry Diameter 1.0 mm Curvature radius 1.0 mm Sag 120-135 microns

Ex-situ curing does not warrant sufficient precision, uniformity and yield. Thermally curable composition with suitable optical properties, low stress, low shrinkage and high temperature resistance would allow to use in-situ curing.



Engel e-motion 55 system PS with Tg ~ 100 °C 60 mm disc, 1.5 mm thick Lens sag 134 microns







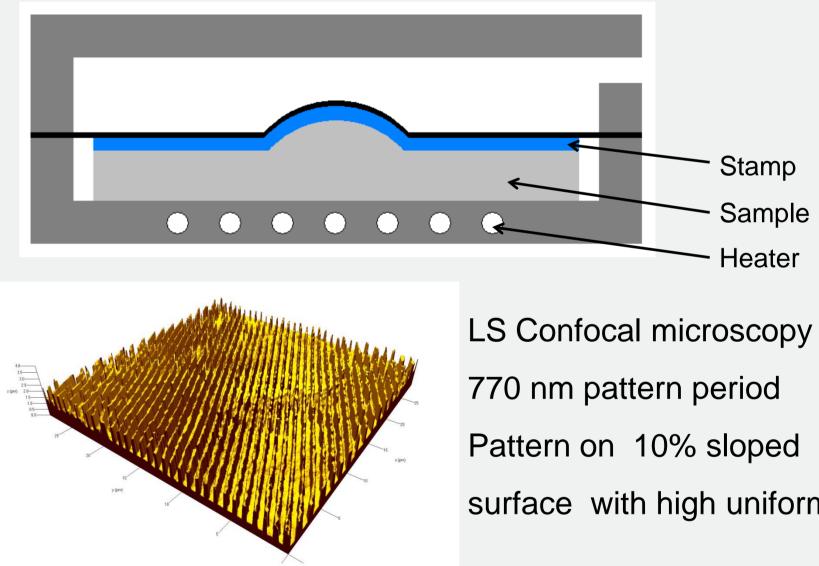
**Abstract:** We aim to develop a processes to form precise free form lens elements on wafer level scale, using PMMA and advanced heatresistant polymers, capable of a reflow assembly. Such optical elements can be used to prepare stacked, multi-level camera modules for the applications in portable electronics, using wafer level packaging techniques. Calculation shows significant cost advantage over usual discrete-assembly-built camera modules. Nanostructured optical surface can provide antireflective or selfcleaning properties so nanostructures on lens surfaces were formed.

# Initial Results with Polystyrene

#### Injection molding modified tool insert.

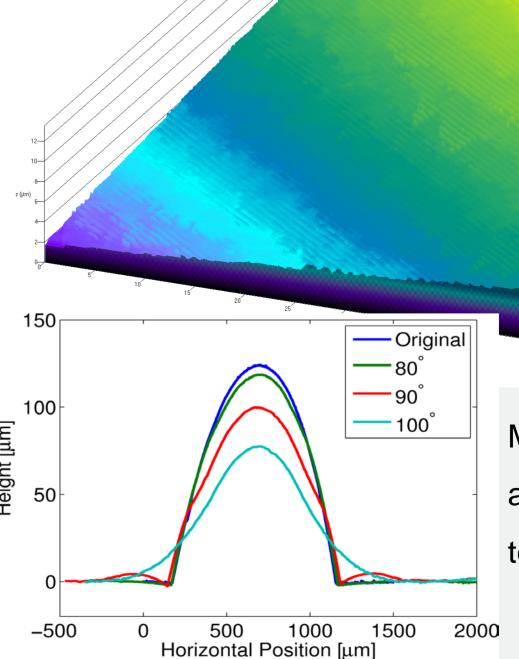
# Nanostructures on double curved surface

Pattern created on Injection molded PS substrates with microlenses was formed by hydrostatic embossing with Obducat 2.5 NIL. Flexible stamp is 188 micron thick polymer foil from Nickel master.



#### Acknowledgments

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Denmark



surface with high uniformity

Macrostructure deformation as a function of nanoimprinting temperature